

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yoshiaki Mori, et al. Art Unit: 1795
Serial No.: 10/026,286 Examiner: Daborah Chacko Davis
Filed: December 20, 2001 Confirmation No.: 1796
Title: Pattern Forming Method and Apparatus Used for Semiconductor
 Device, Electric Circuit, Display Module, and Light Emitting Device

RESPONSE F

Sir:

In response to the Office Action dated January 23, 2008, please amend the above-identified application as follows: